

From As-Grown Diamond to a Controlled Pre-Polish Blank

Automated slicing, precision cutting and configurable laser shaving for high-value diamond materials

As CVD diamond expands into thermal management, optics, advanced tools and semiconductor-related applications, post-growth processing becomes a critical production step. **The objective is not simply to cut diamond—it is to recover usable material and deliver a controlled starting condition for the next finishing step.**

TWO CRITICAL PROCESSING STEPS. ONE AUTOMATED PLATFORM.

- 1 SLICE** — Separate single-crystal or polycrystalline diamond with application-optimized laser processing and controlled cut geometry.
 - 2 SHAVE** — Remove excess material and correct thickness or surface condition before final lapping and polishing. Performance is application-dependent.
- AUTOMATE** — Use vision-assisted alignment, recipe control and automated pick-and-place handling for repeatable, low-touch production.



AP-DC-08G

[View product datasheet](#)

Published AP-DC-08G system highlights

UNATTENDED PRODUCTION

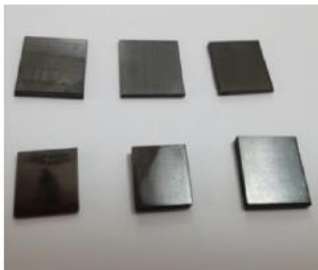
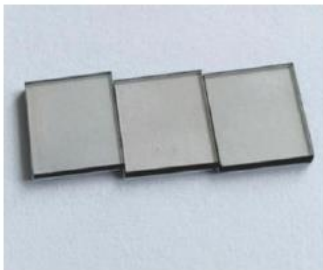
Automated pick-and-place; manual, semi-automatic or fully automated 24/7 operation.

MATERIAL UTILIZATION

Kerf $\leq 30 \mu\text{m}$ for material thickness below 1 mm; application results vary.

CUT-SURFACE QUALITY

Published post-cut surface roughness Ra $< 200 \text{ nm}$; final finishing may still be required.



Have a diamond slicing or pre-polish challenge?

Send the material type, starting dimensions, target thickness, flatness/TTV, surface requirement, finishing allowance and production volume. Our applications team can propose a sample-validation plan.

[Discuss your diamond application](#) | [Explore laser processing systems](#)

Results depend on diamond type, orientation, thickness, geometry, process sequence and acceptance criteria. Sample validation is required.

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